

1612.63479

PATENT APPLICATION *GP/2814*  
*#191 Change*  
*Address*  
*4-24-02*  
*R. Made*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Zhang

Serial No.: 09/468,489

Filed: December 20, 1999

For: THIN FILM TRANSISTOR HAVING  
LIGHTLY AND HEAVILY DOPED  
SOURCE/DRAIN REGIONS AND ITS  
MANUFACTURE

Art Unit: 2814



I hereby certify that this paper is being deposited with the United States Postal Service as FIRST-CLASS mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on this date.

*22 March 02* *[Signature]*  
Date Registration No. 29,367

F-CLASS. WCM Attorney for Applicant  
Appr. February 20, 1998

CHANGE OF MAILING ADDRESS

Assistant Commissioner of Patents  
Washington, D.C. 20231

Dear Sir:

Please direct all future correspondence for this application as follows:

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Respectfully submitted,

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By

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